

Notice of References Cited	Application/Control No. 10/779,609		Applicant(s)/Patent Under Reexamination JEAN-CLAUDE MEYER ET AL.	
	Examiner Jeffrey J. Restifo		Art Unit 3618	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,270,768	06-1981	Nakanishi, Tatsuo	280/610
*	B	US-4,993,740	02-1991	Recher et al.	280/610
*	C	US-5,356,573	10-1994	Kageyama, Norihiko	264/476
*	D	US-5,437,755	08-1995	Lavorel et al.	156/240
*	E	US-5,427,401	06-1995	Liard, Jean	280/609
*	F	US-5,851,331	12-1998	Grenetier et al.	156/235
*	G	US-6,406,054	06-2002	Huyghe, Christian	280/610
*	H	US-D282,387	01-1986	Pichler, Oswald	D21/766
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.